

IN THE UNITED STATE PATENT AND TRADEMARK OFFICE.

In re application of

:

Kazuto HIROKAWA et al.

: Docket No. 2003-0961A

Serial No. 10/617,794

: Group Art Unit

Filed

July 14, 2003

SUBSTRATE POLISHING APPARATUS

VERIFICATION

Commissioner for Patents

P.O.Box 1450

Alexandria, VA 22313-1450

Sir:

I, Tetsuva Hirosawa declare and say:

that I am thoroughly conversant in both the Japanese and English languages;

that I am presently engaged as a translator in these languages;

that the attached document represents a true and accurate English translation of the application Serial No. 10/617,794.

I further declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Signed this 21th day of January, 2004.

Jetenja Ghrama TRANSLATOR